

**Search Notes**

Application No.

10/699,933

Examiner

D. Rutledge

Applicant(s)

SUZUKI, MASAYUKI

Art Unit

2851

**SEARCHED**

Class	Subclass	Date	Examiner
355	53, 67-71	6/12/2004	DR
359	364,365	6/12/2004	DR
359	857-859	6/12/2004	DR
250	492.1,	6/12/2004	DR
250	492.2	6/12/2004	DR

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
355	53,67-71	6/13/2004	DR
359	364,365	6/13/2004	DR
359	857-859	6/13/2004	DR
250	492.1, 492.2	6/13/2004	DR

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
exposure, projection, lithograph\$4, photolithograph\$4, catoptric, optical, microlithograph\$4, 6, six, mirror, reflection	6/12/2004	DR
sixth, concave, convex, mask, reticle, wafer, substrate, diameter, nm, 1500, radius, curvature, slope, flux, maximum	6/12/2004	DR
incident, angle	6/12/2004	DR